

# Velocity-Matched Distributed Photodetectors and Balanced Photodetectors with p-i-n Photodiodes

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**Abstract**—We report on the first demonstration of velocity-matched distributed photodetectors and balanced photodetectors with p-i-n photodiodes. Record-high linear dc photocurrent of 45 mA has been achieved without suffering from thermal damage, thanks to the superior power handling capability of p-i-n photodiodes. A novel fiber alignment technique has been developed to achieve high linear photocurrent. More than 37 dB of common-mode-rejection ratio and 45-dB suppression of laser relative intensity noise over a broad frequency range have been achieved using the distributed balanced photodetectors in an RF fiber-optic link. The frequency response is flat from 1 to 35 GHz.

**Index Terms**—Analog fiber-optic links, balanced photodetectors, high power photodetector, microwave photonics, noise suppression, optical receivers, p-i-n photodetectors, RF photonics.

## I. INTRODUCTION

IN AN externally modulated fiber-optic link, high-speed photodetectors (PDs) with high saturation photocurrent can improve the overall link performance, including the link gain, noise figure, and spurious free dynamic range (SFDR) [1]. When PDs have sufficiently high saturation power, this improvement is limited by the relative intensity noise (RIN) of the laser source and the amplified spontaneous emission noise (ASE) from erbium-doped fiber amplifiers (EDFA). It is known that the laser RIN and EDFA-added noise can be suppressed by balanced receivers [1], [2]. High power balanced receivers are also important for optical heterodyned receivers and optoelectronic generation of high power microwaves and millimeter-waves. Therefore, PDs and, in particular balanced PDs with high linear photocurrent are critical components of high-performance RF photonic links [1]–[3].

Several approaches have been proposed to increase the maximum linear photocurrent of high-speed PDs, including wave-

guide PDs with low confinement factors [4]–[6], traveling-wave photodetectors [7], [8] phototransistors [9], uni-traveling-carrier photodiode [10], and velocity-matched distributed photodetectors (VMDP) [11]–[13], and parallel fed VMDP [14]. Using the VMDP with metal–semiconductor–metal (MSM) PDs, we have previously achieved a saturation photocurrent of 33 mA at 1.55- $\mu$ m wavelength [15]. Bimberg *et al.* also reported on an MSM-based VMDP with a bandwidth above 78 GHz [13]. We have also demonstrated a novel monolithic distributed balanced photodetector with MSM PDs [16] that successfully suppressed broad band (1–12 GHz) laser RIN [17]. Maximum noise suppression of 36 dB was observed at the relaxation oscillation frequency of the DFB laser.

The maximum linear photocurrent in our MSM-VMDP was limited by the catastrophic damage caused by thermal runaway. p-i-n PDs have higher threshold for thermal runaway than MSM PDs. It was previously shown that MSM PDs fail at junction temperatures of  $\sim$ 700 K [18], whereas p-i-n can stand junction temperatures above 900 K [19]. We developed a theoretical model to carry out detailed analysis of the thermal runaway issues and found that the dark current ( $I_{\text{dark}}$ ) and the effective barrier height ( $q\phi_b$ ) are the fundamental parameters in the failure mechanism of high power PDs. Our investigation also showed that junction PDs (such as p-i-n) with high  $q\phi_b$  were expected to perform better than metal–semiconductor contact PDs (such as MSM or Schottky) for high power operation. Further details of our analysis are reported elsewhere [20]. The uniform electric field distribution in p-i-n is also advantageous for linear operation under high power illumination. Moreover, the fabrication of high bandwidth MSM PDs demands sophisticated submicron e-beam writing and thin MSM fingers are vulnerable to failure caused by high photocurrents. Therefore, VMDP with p-i-n PDs are of great interest for high power photodetection.

In this paper, we report on the first demonstration of the VMDP with p-i-n PDs. Record-high linear photocurrent of 45 mA has been achieved. No thermal runaway was observed for photocurrent above 55 mA. We have also found that the fiber position for maximum responsivity is different from that for maximum linear photocurrent. A novel technique of offset launching of the input power helped attain more uniform distribution of photocurrents. Our VMDP has a flat frequency response up to 35 GHz, though there is an initial drop at low frequency due to slow carrier diffusion. We also fabricated a distributed balanced photodetectors with p-i-n PDs and successfully suppressed broad-band RIN and EDFA added noises by more than 43 dB.

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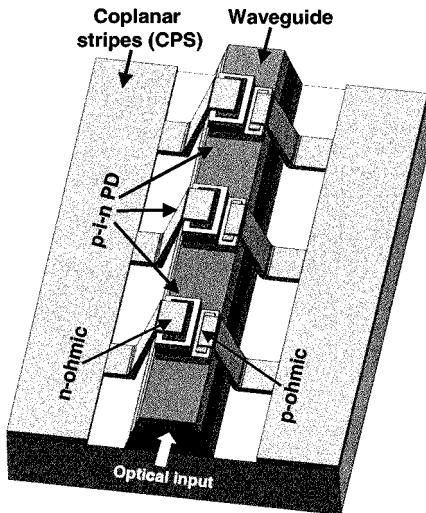


Fig. 1. Schematic of the VMDP showing the passive optical waveguide, active p-i-n PDs and microwave transmission line.

## II. DESIGN AND FABRICATION

The schematic structure of the VMDP is illustrated in Fig. 1. A linear array of p-i-n PDs is periodically distributed on top of a passive optical waveguide. Optical signal is evanescently coupled from the passive waveguide to the active p-i-n PDs. Photocurrent generated from the individual PDs are added in phase through a coplanar strips (CPS) microwave transmission line that is velocity-matched to the optical velocity in the waveguide. The characteristic impedance of the periodically loaded transmission line is designed to have a value of  $50\ \Omega$ . The PDs are kept below saturation by coupling only a small fraction of optical power to each PDs.

The optical waveguide was grown with following layers: a 400-nm-thick  $\text{In}_{0.52}\text{Al}_{0.36}\text{Ga}_{0.12}\text{As}$  lower cladding layer, a 600-nm-thick  $\text{In}_{0.52}\text{Al}_{0.269}\text{Ga}_{0.211}\text{As}$  core region, a 200-nm-thick  $\text{In}_{0.52}\text{Al}_{0.36}\text{Ga}_{0.12}\text{As}$  first upper cladding layer that has a Be doping concentration of  $5 \times 10^{17}\ \text{cm}^{-3}$  in the upper half; a 150-nm-thick  $\text{In}_{0.52}\text{Al}_{0.48}\text{As}$  second upper cladding layer with a doping concentration of  $5 \times 10^{18}\ \text{cm}^{-3}$  and a 150-nm-thick  $\text{In}_{0.52}\text{Al}_{0.382}\text{Ga}_{0.98}\text{As}$  as third upper cladding layer that was gradually increased in doping to a concentration of  $1 \times 10^{19}\ \text{cm}^{-3}$  at the top of the layer. A 10-nm-thick  $\text{In}_{0.52}\text{Ga}_{0.47}\text{As}$  layer with a Be doping concentration  $> 1 \times 10^{19}\ \text{cm}^{-3}$  was used on this layer for p-ohmic contacts. The 250-nm-thick absorption region is located on top of the passive waveguide for evanescent coupling. Finally, a 200-nm-thick  $\text{In}_{0.52}\text{Al}_{0.382}\text{Ga}_{0.98}\text{As}$  with a Si doping concentration  $> 1 \times 10^{19}\ \text{cm}^{-3}$  was employed for n-ohmic contacts. Graded layers are incorporated in the structure to reduce the minority carrier trapping at heterointerfaces.

The fabrication process is described in the following: First, the PD mesas were isolated by etching away the active layers from the wafer except from the places where PDs are located. Top n-ohmic and bottom p-ohmic contact metals were then deposited and lifted-off. A rapid thermal annealing (RTA) process at  $410\ ^\circ\text{C}$  for 10 s is performed to reduce the contact resistance of the device. A  $\text{Si}_3\text{N}_4$  etch mask was deposited by plasma-enhanced chemical vapor deposition (PECVD). Optical ridge

waveguide with a  $1.5\text{-}\mu\text{m}$  depth was formed by wet chemical etching. Special care has been taken to ensure the smooth, continuous transition between the passive waveguides and the active PD sections. After defining the waveguides,  $\text{Si}_3\text{N}_4$  was removed using buffered HF (BOE). A thin PECVD  $\text{Si}_3\text{N}_4$  film of  $1500\text{-}\text{\AA}$  thickness was then deposited all over the sample to achieve three purposes. First, it covers the mesa walls and thus prevents the interconnect metals from touching the InGaAs layer—a potential contributor of high dark current in a PD. Second, it passivates the surface of the wafer, and finally it serves as the dielectric layer between the CPS transmission lines and the substrate, which eliminates the leakage current between the CPS. The CPS transmission lines were formed by standard lift-off process to connect the distributed PDs.

To increase the fiber coupling efficiency [21], the optical waveguide is designed to have a large optical core in the vertical direction. Multimode waveguide in the lateral direction is employed so that the PD and its contacts can be placed on top of the waveguide. As will be shown later, this design can minimize the optical loss at waveguide/PD transition. However, in a multimode waveguide, different mode propagates at different velocities. Thus, the microwave velocity can only be matched to the group velocity of only one optical mode. Thus there is some inherent velocity mismatch in multimode devices. However, the mismatch is small ( $< 10\%$ ) and the bandwidth limit due to velocity mismatch is greater than 150 GHz, which is much higher than the transit time-limited bandwidth of our current device. Moreover, our beam propagation method (BPM) simulation shows that more than 90% of the input power is coupled to the fundamental mode. When the design target goes above 100 GHz, the single-mode waveguide will ensure better performance.

## III. DEVICE CHARACTERISTICS

The dc responsivity is  $0.42\ \text{A/W}$  at 1-V bias without antireflection (AR) coating. This responsivity can be further improved by employing air-bridges to connect PDs with the microwave transmission line, which prevent direct metal deposition on the sidewalls of the waveguide. The reverse bias breakdown is  $\sim 1.5\ \text{V}$ . The low breakdown is caused by the diffusion of p-type dopants from the lower contact layers into the InGaAs absorbing layer during the epitaxial growth. The fiber coupling efficiency can be improved by integrating a spot-size converter for better mode-matching with fiber. Coupling efficiency as high as 90% has been reported [22]. With both AR coating and spot size converter, the responsivity can potentially be increased to  $0.9\ \text{A/W}$ . The spot-size converters also reduce the optical power density at facets and therefore increase the optical damage power level. The microwave characteristics of the loaded CPS is measured by a HP 8510C network analyzer. The measured characteristic impedance matches very well to  $50\ \Omega$  (within 3%) for a broad frequency range.

One of the main tradeoffs in the design of p-i-n VMDP is the placement of Ohmic contacts. Fig. 2 shows three different contact schemes: (a) parallel contacts on a continuous waveguide; (b) tandem contacts on a continuous waveguide; and (c) parallel contacts with lower contact outside the waveguide. The contact

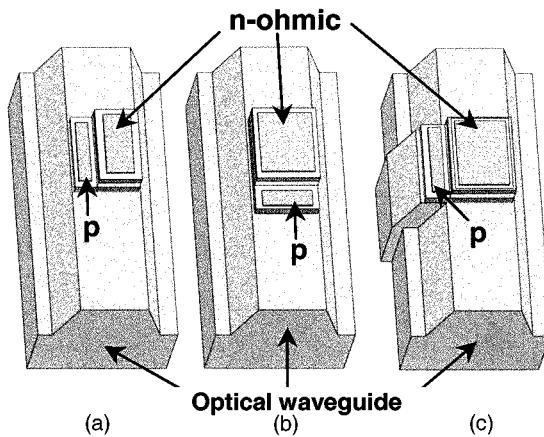


Fig. 2. Schematic of three different contact schemes. (a) Parallel on continuous waveguide. (b) Tandem on continuous waveguide. (c) Parallel contacts with lower contact outside the waveguide.

area for each PD is  $20 \times 2.5 \mu\text{m}^2$ . The spacing between the n and p contacts is  $2 \mu\text{m}$ . In our device, the p-ohmic contact is the lower contact, which is close to the core of the passive waveguide. We experimentally investigated the performances of the VMDPs with different contact schemes. Our results show that contact scheme (a) exhibits the best performance with the lowest loss and more uniform photocurrent distribution along the PD array. This geometry ensures the highest responsivity ( $0.42 \text{ A/W}$ ) and linearity (more than  $45 \text{ mA}$ ).

The tandem contacts on continuous waveguide are not efficient for guiding light to distant PDs. The presence of p-metal on top of waveguide causes high optical loss. Moreover, during the thermal annealing process, part of the p-metal is diffused into the upper cladding of the waveguides. This causes additional free carrier absorption. We measured the lowest responsivity of  $\sim 0.22 \text{ A/W}$  and linear photocurrent of  $\sim 5 \text{ mA}$  in the devices with this type of contacts.

In scheme (c) that has parallel contacts with the lower contact outside the waveguide, lateral discontinuity in the waveguide introduces excessive optical loss. As a result, most of the propagating power is lost at the PD-waveguide interface. Although the responsivity is only slightly lower ( $0.36 \text{ A/W}$ ) than that of scheme (a), the linear photocurrent is much lower ( $\sim 10 \text{ mA}$ ) in this configuration. The PDs beyond the first one in the VMDP receives negligible power, and thus the maximum linear photocurrent of the VMDP remains limited by the first PD.

To characterize the distribution of photocurrents within the VMDP, we fabricated test VMDPs with separate electrical contacts for each PDs. The measurement results are shown in Fig. 3. When the fiber is positioned to optimize the overall responsivity of the VMDP ( $0.42 \text{ A/W}$ ), the responsivity distribution has a very steep decay [Fig. 3, line a]. The first PD contributed 73.8% of the total photocurrent. The maximum linear photocurrent is  $22 \text{ mA}$ . If the fiber is moved in the vertical direction to optimize the response of the second PD instead of the entire VMDP, more uniform distribution of photocurrent is obtained. The responsivity of the overall VMDP decreased slightly to  $0.39 \text{ A/W}$ , [Fig. 3, line b] however, the maximum linear photocurrent increased to  $35 \text{ mA}$ . This is because more PDs are contributing to the total photocurrent when the first PD reaches saturation. If we

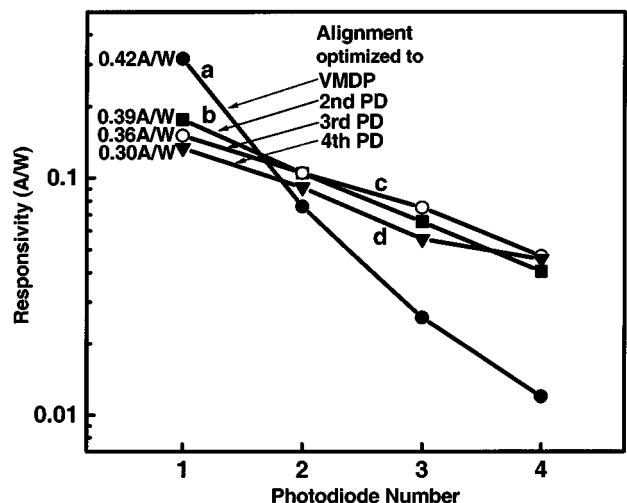


Fig. 3. Measured responsivity of each PDs in the split contact VMDP. Trace a shows the data for optimized alignment to the VMDP for highest responsivity. Trace b, c, and d show data for optimizing the fiber alignment to the second, third, and fourth PD in the array.

move the fiber again to optimize response of the third PD, the maximum linear photocurrent of the VMDP is increased further to  $45.5 \text{ mA}$ . The overall responsivity became  $0.36 \text{ A/W}$ . The distribution of responsivity under this coupling condition is shown in Fig. 3, line c. The offsets of the fiber position for lines b and c are  $\sim 0.09$  and  $\sim 0.21 \mu\text{m}$ , respectively, in the vertical direction, with reference to the fiber position for (a). Aligning the input power to optimize the photocurrent of a further distant PD (such as the fifth or sixth one) makes the power distribution more uniform. Moving the fiber in the later direction has little effect on the distribution of photocurrents.

Careful observation of Fig. 3 reveals two different slopes for the photocurrent distribution. When the input power is aligned for optimum responsivity of the VMDP, the slope of the curve is very high indicating a fast decay of the input power. As we move the fiber to optimize the alignment to second PD in the array, the slope abruptly reduces to a lower value. When the fiber is aligned to optimize the responsivities of the third or fourth PD, the slope of the curves in Fig. 3 keeps decreasing slowly, resulting in a more uniform distribution of the optical power.

The explanation for the above observation is as follows. Because the first photodiode is located very close to the facet ( $100 \mu\text{m}$  away), the optical field coupled into VMDP has not reached the steady state distribution yet. The transient field can be directly coupled into the photodiodes, resulting in higher photocurrents in the first photodiode. Therefore, when we align the fiber by maximizing the overall response of the VMDP, the fiber-to-waveguide coupling is actually not optimized. Though the absorption of the transient field helps increase the overall quantum efficiency, the extra photocurrent concentrates in the first photodiode and causes it to saturate at lower overall photocurrent. The photocurrents of the photodiodes farther away from the input facet are less influenced by the transient field and, therefore, are better monitors for the fiber alignment.

An alternative explanation of the alignment sensitive intensity distribution over different photodiodes is coupling to different waveguide modes. Though our waveguide was designed to be

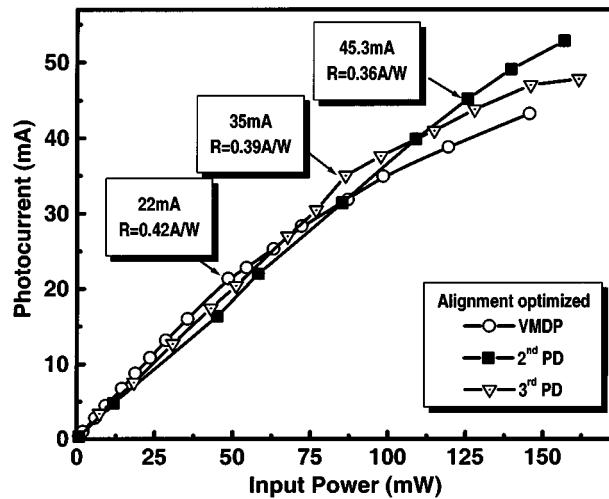


Fig. 4. Measured dc linear photocurrents for three different input fiber positions. The linear current improves greatly when the input power is optimized to a distant photodiode.

single mode, it was very close to the cutoff of the second mode. Due to variation of epitaxial growth, it is possible our waveguide could support two modes. Coupling to different modes could also result in different photocurrent distribution over different photodiodes. More detailed analysis is needed to identify the exact mechanism.

Fig. 4 shows the photocurrent versus optical power for the three alignment schemes: a) maximum overall responsivity; b) maximum photocurrent for the second PD; and c) maximum photocurrent for the third PD. The maximum linear photocurrent of 45 mA was obtained for scheme c). To our knowledge, this is the highest linear dc photocurrent reported in high-frequency photodetectors.

Our finding also suggests new VMDP structures with built-in monitor PDs for optimum fiber alignment. The photocurrent of a PD farther away from the input facet can be used as a better monitor for the fiber alignment. In addition to the regular array of PDs of the VMDP, we can add an additional monitoring PD in the middle of the waveguide (e.g., between the fourth and the fifth PDs). By optimizing the photocurrent of the monitoring PD, we can ensure high linear photocurrent in the device. The photocurrent distribution can be made even more uniform by tapering the optical coupling between the waveguide and the photodiodes [5], or by splitting power equally to a parallel array of photodiodes as in the parallel-fed VMDP [14].

In contrast to the MSM VMDP we reported previously [14], the p-i-n VMDP does not fail at the maximum linear photocurrent. In fact, our device survives at photocurrent as high as 55 mA. If we continue to increase the photocurrent, eventually the facet of the optical waveguide is damaged at 200 mW. Even under this circumstance, the active PDs of the p-i-n VMDP remains undamaged. In fact, we can couple light in from the undamaged facet at the other end, and obtain the same level of maximum linear photocurrent as before. Fig. 5 shows the top-view and side-view photograph of a burnt facet when more than 200 mW of input power is launched into the waveguide. It can be seen that the damage is localized at the

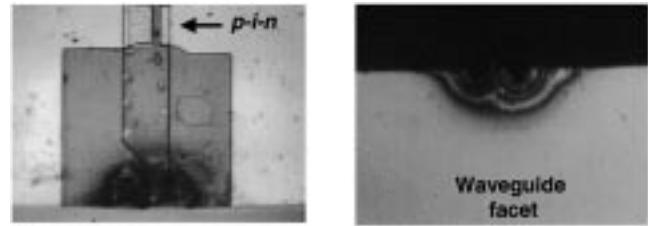


Fig. 5. Burnt facet of a VMDP after more than 200 mW of power is coupled to the passive waveguide. Top view is on the left and edge view is on the right. The device electrical characteristics remain unchanged even after the facet burn.

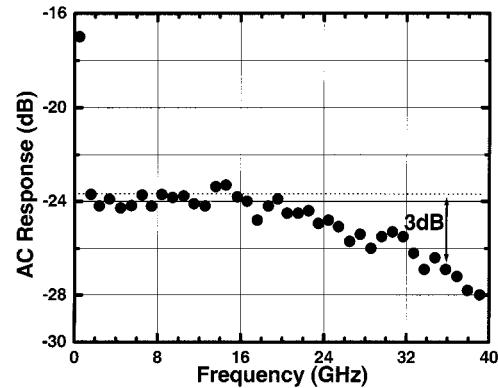


Fig. 6. Measured frequency response of the p-i-n VMDP with optical heterodyning. Neglecting the sharp rolloff below 1 GHz, the device has a 3-dB bandwidth >35 GHz.

facet. A spot-size converter can reduce the input power density and increase the threshold power for facet burn.

We used both frequency and time domain measurements to characterize the ac response of the VMDP. The frequency domain measurement was performed by optical heterodyning method using two external cavity tunable lasers at 1550 nm. The optical signals are combined by a 3-dB coupler, and coupled to the VMDP through a fiber pickup head. The output is collected by a 50-GHz probe and monitored by an RF power meter. The calibrated frequency response of the VMDP is shown in Fig. 6. The ac response has a quick rolloff at low frequencies (below 1 GHz) and then remains almost flat. The initial rolloff ( $\sim 7$  dB) at low frequency is due to the slow carrier diffusion in the active region, which is caused by unintentional migration of p-dopants (Be) during epitaxial growth. Excluding the low frequency rolloff, the 3-dB frequency is 35 GHz. The ac quantum efficiency is 3.5 dB lower than the dc quantum efficiency. The maximum linear ac photocurrent will be reduced to  $\sim 20$  mA. Therefore, it is important to eliminate the low frequency rolloff.

The low frequency rolloff can be eliminated by inserting an undoped setback layer in the p-cladding layer. The breakdown voltage of the PD can also be increased. Devices using the new epitaxial structures are now being fabricated. Another issue of our current devices is the high contact resistance of the lower Ohmic contact, which results in low  $RC$ -limited bandwidth. Our current epitaxial layer structure does not have an effective stop etch layer before the lower Ohmic contact layer. As a result, the contact is actually formed on the InGaAlAs layer with low

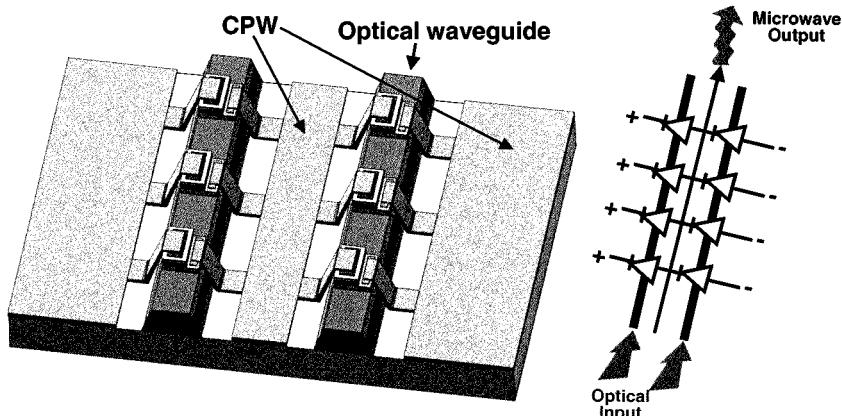


Fig. 7. Schematic structure and principle of the distributed balanced photodetector. Multiple balanced photodetector pairs are cascaded in series along a CPW to increase saturation photocurrent. The p-i-n PDs provide the capacitance and resistance to the CPW and help to slow down the microwave velocity of the receiver matching it to that of optical velocity.

p-doping concentration. In the new epitaxial layer design, we have inserted a stop etch layer to improve the contact resistance. The new device should exhibit higher frequency response.

#### IV. DISTRIBUTED BALANCED PDs

We designed a distributed balanced photodetector structure using p-i-n PDs. Fig. 7 shows the schematic and the basic principle of the device. It consists of two input optical waveguides, two arrays of high-speed p-i-n PDs distributed along two passive optical waveguides, and a coplanar waveguide (CPW) microwave transmission line with a characteristic impedance of  $50 \Omega$  when loaded. The detector operates in balanced mode when a voltage bias is applied between the two ground electrodes of the CPW. The PD arrays provide periodic capacitance loading to slow down the microwave velocity. By adjusting the length and separation of the PDs, velocity matching between the CPW and the optical waveguides is achieved. Detailed description of a similar device with MSM PDs, experimental setup, biasing scheme, several references on balanced detectors and typical fiber-optic links with balanced detectors were reported in [16]. A more recent work on waveguide fed monolithically integrated balanced detectors have been reported by Unterboersch *et al.* [23].

The common-mode-rejection-ratio (CMRR) is an important parameter of a balanced receiver when high RIN suppression is considered. CMRR, defined as  $CMRR = 20 \cdot \log(i_{COM}/i_{DIFF})$  (where,  $i_{COM}$  is the total current and  $i_{DIFF}$  is the difference in the magnitude of the photocurrent of the individual PDs), indicates how well matched the PDs are in the receiver. Fig. 8 depicts the measured CMRR versus photocurrent. Very high CMRR ( $>37$  dB) was obtained for a wide range of photocurrents (from a few nA to 31 mA). This is attributed to the well-matched characteristics of the PDs in our monolithic balanced detectors.

Fig. 9 shows the RF spectra of the output from a distributed balanced receiver in the unbalanced (only one waveguide is illuminated) and the balanced mode using the test setup described in [17]. Suppression of the noise floor by 43 dB has been observed in the balanced mode over a wide frequency range from a few megahertz to 8 GHz with a total photocurrent of 31 mA on each

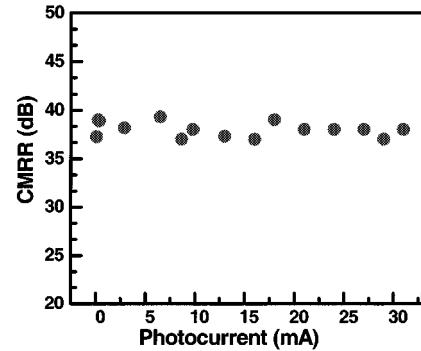


Fig. 8. CMRR versus photocurrent for the distributed balanced receiver. The high CMRR results from the closely matched photodiode characteristics of the individual p-i-n diodes.

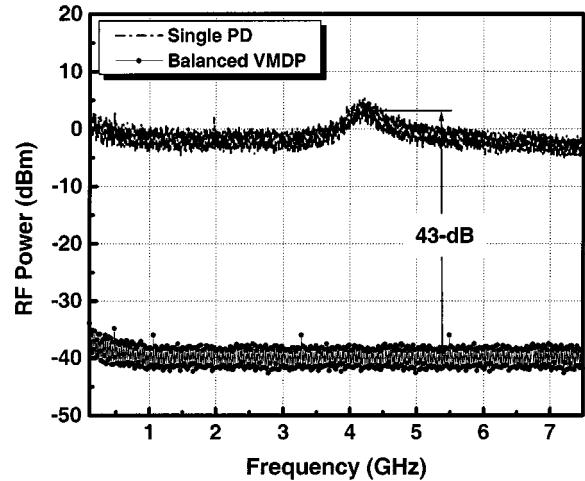


Fig. 9. The noise spectra of a DFB laser measured by the distributed balanced photodetector in unbalanced mode (upper trace) and balanced mode (lower trace). The receiver suppresses RIN noise by more than 43 dB and reaches the shot noise floor.

array of the receiver. The RIN suppression is slightly higher than the CMRR shown in Fig. 8 because we fine-tuned the optical input to each waveguide to maximize the RIN suppression. To our knowledge, this is the highest suppression of RIN noise by balanced photodetectors at high frequencies. Shot-noise-limited

performance has been achieved at high photocurrent by canceling out the laser RIN.

## V. CONCLUSION

We have successfully demonstrated a velocity-matched distributed photodetector with p-i-n PDs. A high linear dc photocurrent of 45 mA has been achieved. In order to increase the dc linear photocurrents, a novel alignment technique is proposed and demonstrated. The VMDP has a flat frequency response from 1 to 35 GHz. A low frequency rolloff due to slow carrier diffusion is also observed. Distributed balanced photodetectors have also been fabricated and a record high suppression (43 dB) of laser RIN over a broad frequency range has been achieved. We are now in the process of fabricating a new epitaxial structure to eliminate the long diffusion tail and improve the contact resistance.

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